Procedural Review Voting Sheet 2014 Cycle 3

REGION: North America COMMITTEE: Silicon Wafer EVENT: SEMICON West 2014 DATE OF MEETING: 07/08/2014 PLACE OF MEETING: Marriott Hotel, San Francisco, California COMMITTEE CO-CHAIRS: Dinesh Gupta (STA), Noel Poduje (SMS) SEMI STAFF: Kevin Nguyen

A&R Voter: Name/Company Date: 200X/MM/DD

I. Document Number & Title

Document	New Standard: Guide for the Measurement of Trace
4844C	Metal Contamination on Silicon Wafer Surface by
	Inductively Coupled Plasma Mass Spectrometry

II. Tally (Staff to fill in)

Voting Tally: As-cast tally after close of voting period

A minimum of 60% of the voting interests that have voting members within the technical committee must return votes. (Regulations \P 9.6.1)

	Return	Distribution Return Rate
Yellow	62	\div 92 = 67.4% >=60%
Lilac & Others	33]
Total Vote	95]
Reject	0]
Accept	36]

A&R		Not approved
AGA	Re	ason:

III. Rejects There was no reject received for ballot 4844C.

IV. Comments

Co	omment 1	

	F		renced	*TF/Committee to fill in if necessary			
Con		Fr	om	Jean-Marie Collard (Solvay)			
Comment		Com	iment	Well done			
		Discu	ussion				
	x			tee agreed to do one of the following actions.			
	^	*No		s required in this step.			
		Х		er action was taken by the committee.			
				the task force for more consideration.			
			New Bus	siness			
			Other				
	Editorial Change						
Act	Case 1: No vote in this section :						
ion p			To be included and voted on in § 5. Summary of Editorial Changes.				
rop			Case 2:	Voted in this section :			
Case 1: No vote in this section : To be included and voted on in § 5. Summary of Editorial Changes. Case 2: Voted in this section : Original section number and at least one full sentence are require "TO" fields.				section number and at least one full sentence are required in "FROM" and lds.			
			FROM:	Section xxx			
		1	To: Sec	tion xxx			
			Justific	ation (I <mark>f necessary)</mark>			
			FROM:	Section xxx			
		2	To: Sec	tion xxx			
			Justific	ation (If necessary)			

Motion by/2nd		nd Name (Company)/Name (Company)	
Vote XX-XX Motion passed (or failed)			
A&R		Not approved	
		ason:	

V. Summary of Editorial Changes

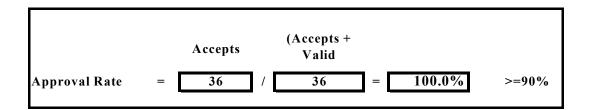
There was no editorial change proposed for ballot 4844C.

VI. Approval Conditions Check

APPROVAL CONDITION 1: All negatives have been discussed and were withdrawn, found not related, or not persuasive. (Regulations \P 9.6.2)

APPROVAL CONDITION 2: At least 90% of the sum of the valid accept and reject votes must be accept. (Regulations \P 9.6.3)

Note: if both approval conditions are not satisfied, the document fails.



A&R		Not approved
Aun	Re	eason:

VII. Safety Check

See § 14 of the Regulations for further information

N	x		This is not a Safety Document: when all safety-related information is removed, the document is still technically sound and complete.					
Motion		This is a Safety Document: when all safety-related information is removed, the document is not technically sound and complete.						
			Safety Checklist (Regulations ¶ 14.3) is complete and has been included with the document throughout the balloting process.					
Ν	/loti	on b	y/2nd by	Noel Poduje (SMS)/Naoyuki Kawai (Tokyo University)				
	D	Discussion None						
	Vote 14-0 Motion passed							
	A&F	R Not approved						

Reason:

VIII. Intellectual Property Check Note: This ballot may be all or part of a Standard or Safety Guideline. This IP check applies to the entire Standard or Safety Guideline. See § 15 of the Regulations for further information

х	The meeting chair asked those present in person or by electronic link, if they were aware of any potentially material patented technology or copyrighted items* in the Standard or Guideline.							
	х		otentially m nown	naterial	patented technology or copyrighted items	GO TO SECTION IX		
		know	n but a Lei	tter of A	ented technology or copyrighted items are Assurance (LOA) or copyright release for n obtained or presented to the committee.	GO TO SECTION IX		
		Potentially material patented technology or copyrighted items are known but an LOA or copyright release for some of the material(s) has NOT been obtained or presented to the committee						
	M		Ask ISC f	Ask ISC for special permission to publish				
	MOTION		Quit activ	Quit activity				
	N		Wait for L	OA for	patented technology or release of copyrighted	d items.		
	Мо	tion by	y/2 nd by	Name (Company)/Name (Company)				
		Discus	sion	XXXX				
	Vote			XX-XX				
	-	inal A	ction		Motion Passed			
			CION		Motion Failed			
٨	&R	I	Not appro	ved				
A	an	Reason:						

* Note: Such potentially material patented technology or copyrighted items might have become known since the Standard or Safety Guideline was last reviewed, or might become relevant due to this ballot.

IX. Action for this document

	x		This document passed committee review as balloted and will be forwarded to the A&R for procedural review.							
Motion		This document passed committee review with editorial changes and will be forwarded to the A&R for procedural review.								
 		This docur	nent	failed committee review and will be returned to the task force for rework.						
		This docur	nent	failed committee review and work will be discontinued.						
Motion by/2nd by Noel Poduje (SMS)/Naoyuki Kawai (Tokyo University)				el Poduje (SMS)/Naoyuki Kawai (Tokyo University)						
	Discussion			ne						
		Vote	15-	0						
	Fina	al Action	x	Motion passed						
	1 1110			Motion failed						

		Approved
A&R		Not approved
	Re	eason: